



## Opto Edu A63.7069 Scanning Electron Microscope Instrument Std 8x~300000x

Our Product Introduction

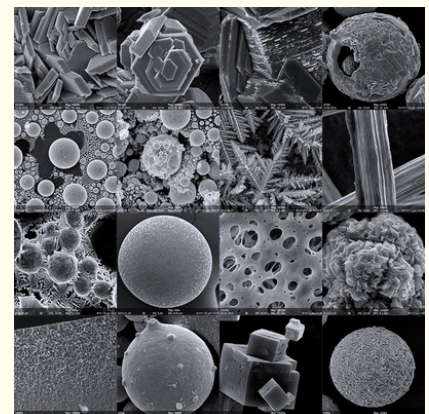
### Basic Information

- Place of Origin: China
- Brand Name: CNOEC, OPTO-EDU
- Certification: CE, Rohs
- Model Number: A63.7069
- Minimum Order Quantity: 1 pc
- Price: FOB \$1~1000, Depend on Order Quantity
- Packaging Details: Carton Packing, For Export Transportation
- Delivery Time: 5~20 Days
- Payment Terms: T/T, West Union, Paypal
- Supply Ability: 5000 pcs/ Month



### Product Specification

- Resolution: 3nm@30KV(SE); 6nm@30KV(BSE)
- Magnification: Negative Magnification: 8x~300000x; Screen Magnification: 12x~600000x
- Electron Gun: Tungsten Heated Cathode-Pre Centered Tungsten Filament Cartridge
- Accelerating: 0~30KV
- Objective Aperture: Molybdenum Aperture Adjustable Outside Vacuum System
- Specimen Stage: Five Axes Stage
- Highlight: **opto edu scanning electron microscope instrument**  
**300000x scanning electron microscope instrument**



for more products please visit us on [cnoec.com](http://cnoec.com)

## Product Description

8x~300000x With Detector SED+BSED+CCD, Five Axes Stage (Auto X/Y, Manual Z/R/T)

Upgradeable LaB6, X-Ray Detector, EBSD, CL, WDS, Coating Machine And Etc.

Multi Modification EBL, STM, AFTM, Heatign Stage, Cryo Stage, Tensile Stage, SEM+Laser And Etc.

Auto Calibration, Auto Faulty Detection, Low Cost For Maintain & Repair

Easy & Friendly Operation Interface, All Controlled By Mouse In Computer Windows System (Included)



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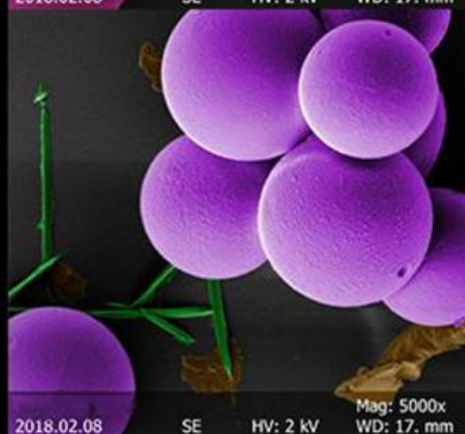
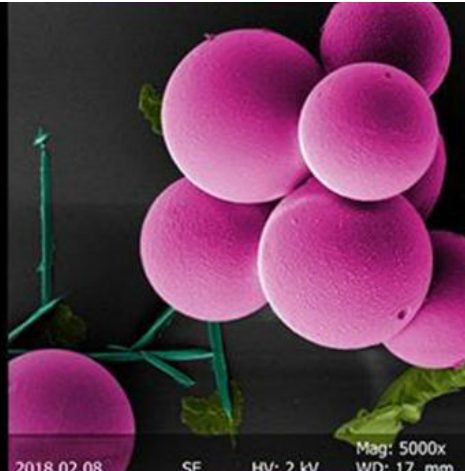
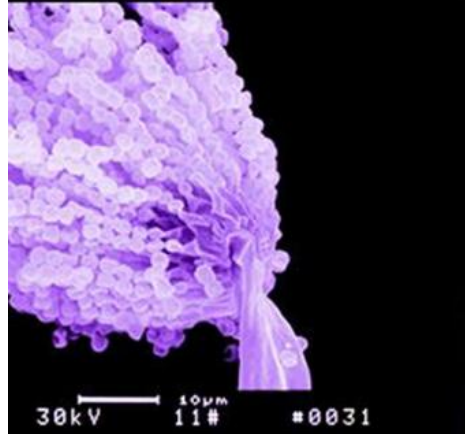
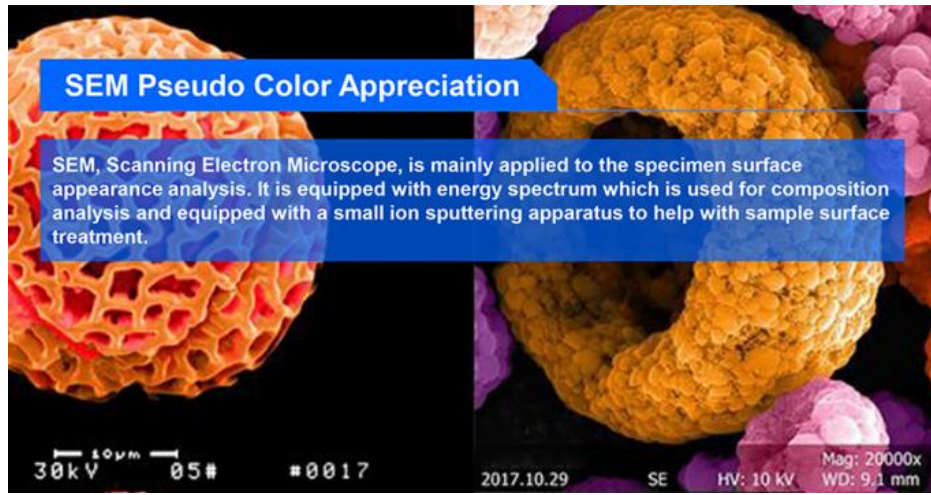
## A63.7069

### Tungsten Filament Scanning Electron Microscope, SED+BSDE+CCD, 8x~300000x



## SEM Pseudo Color Appreciation

SEM, Scanning Electron Microscope, is mainly applied to the specimen surface appearance analysis. It is equipped with energy spectrum which is used for composition analysis and equipped with a small ion sputtering apparatus to help with sample surface treatment.



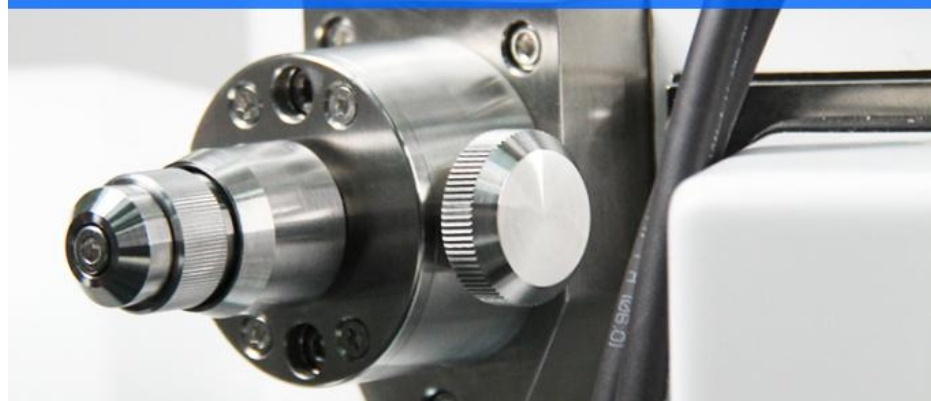


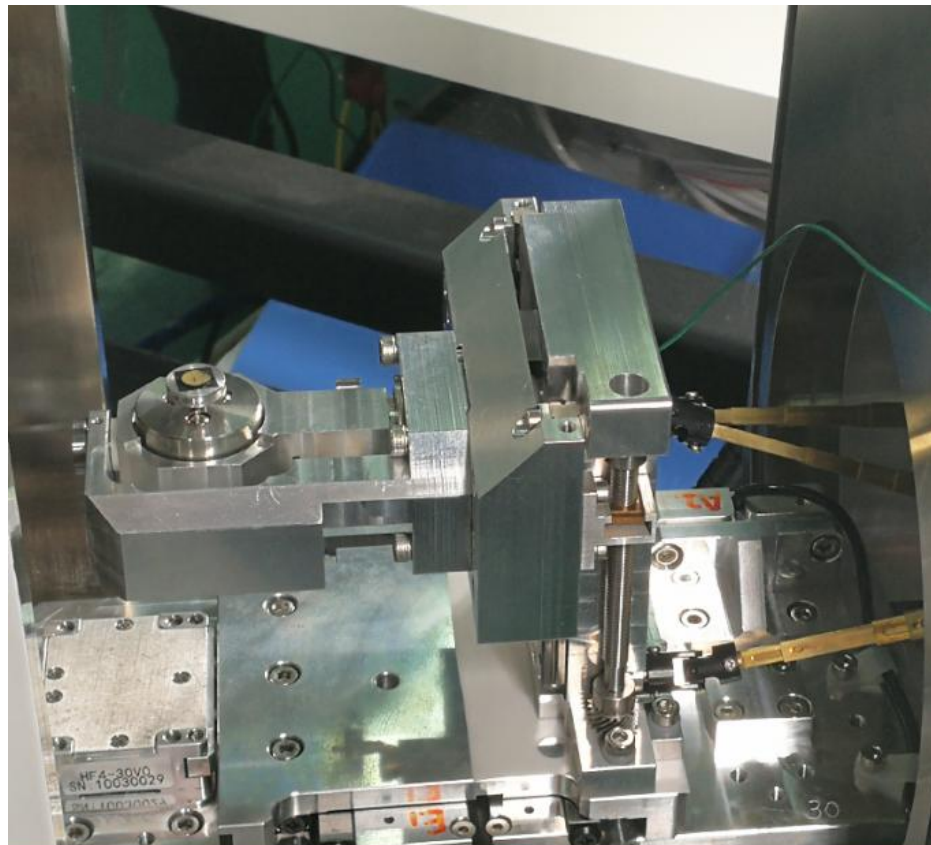


The Isolating Valve Ensures That The Upper Vacuum Is Not Affected When The Sample Room Is Opened

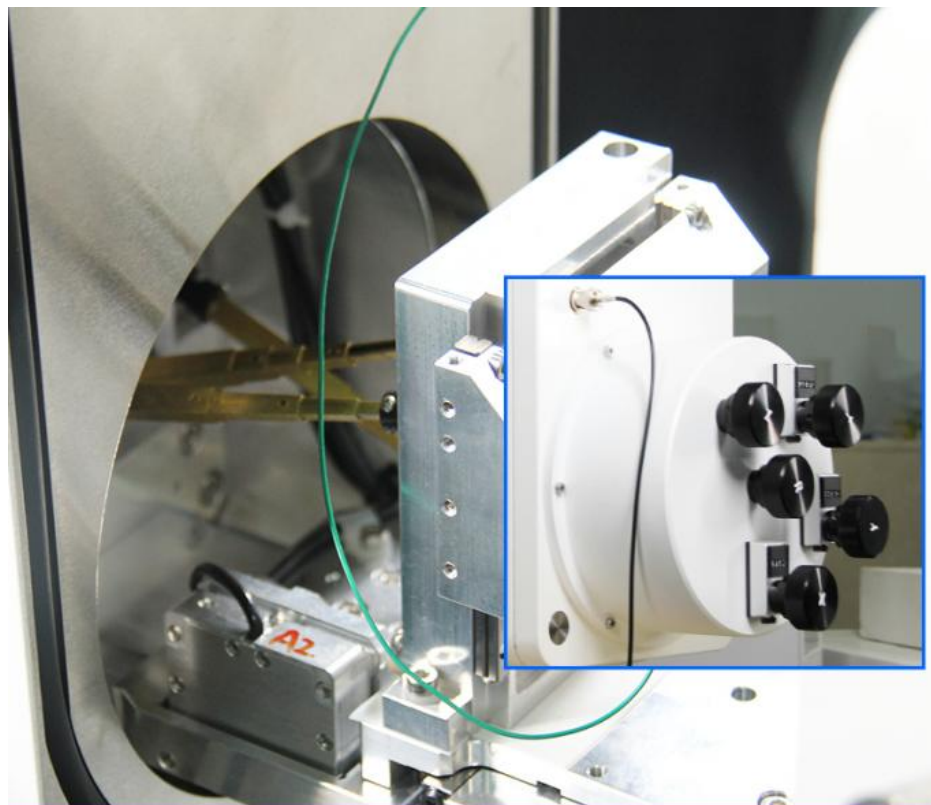


3 Molybdenum Objective Apertures, Adjustable Outside Of Vacuum System, No Need Disassemble Objective To Change Aperture

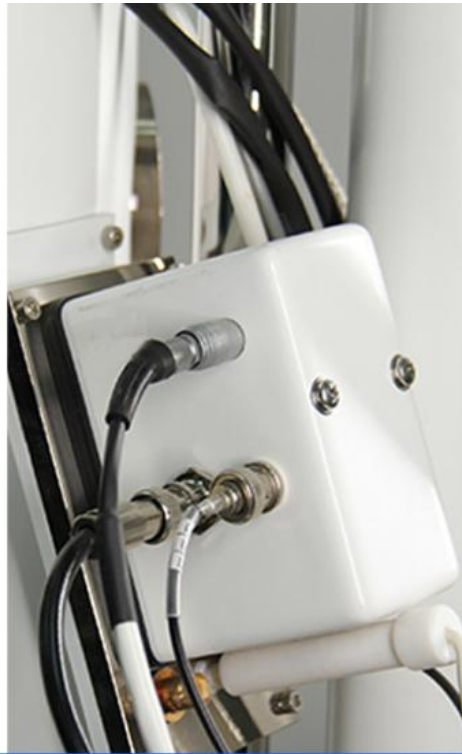
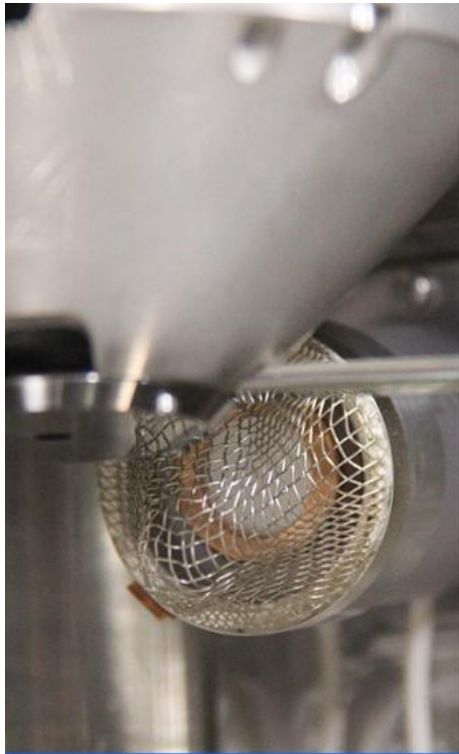




Sample Room Vacuum  $>2.6E-3Pa$



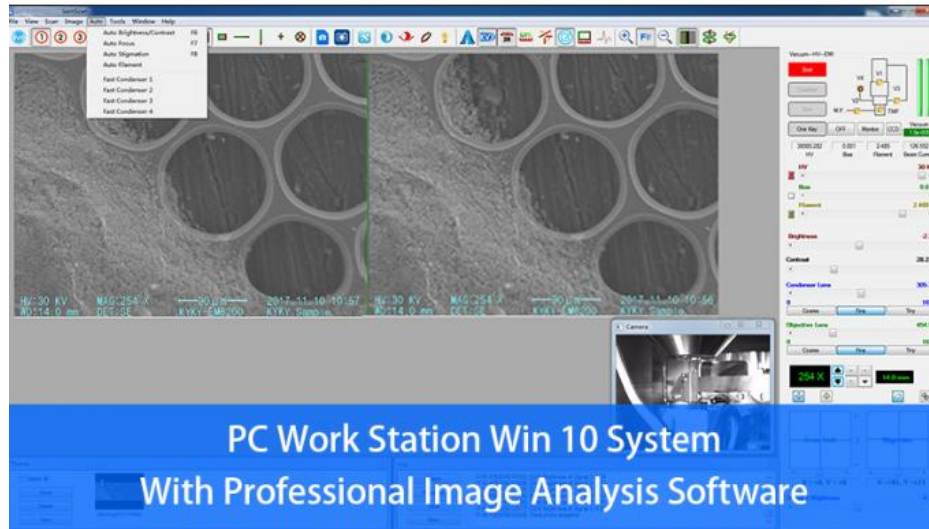
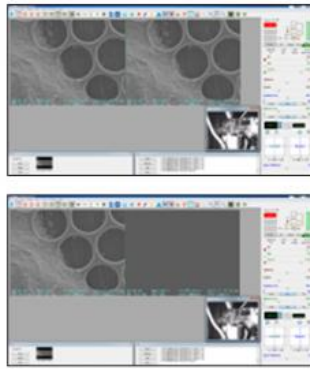
5 Axes Stage, 4 Auto +1 Manual Control  
Touch Alert & Stop Function



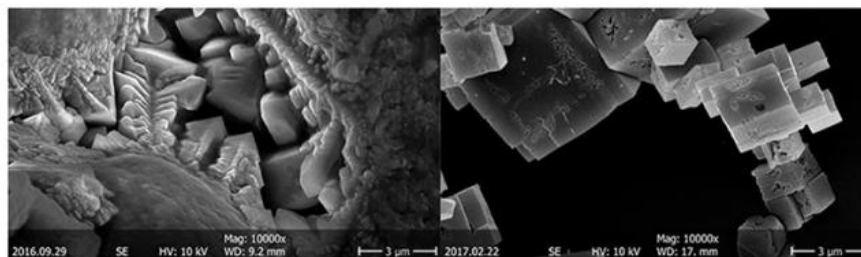
3 Detectors: SE, BSE, CCD  
High Vacuum Secondary Electron Detector  
(With Detector Protection)



Optional Accessory Connection Interface



A63.7069 Software Main Function		
High pressure regulation	Vertical line scan	Potential shift regulation
Filament current regulation	Condenser adjustment	Multi scale measurement
Astigmatic adjustment	Electric to central adjustment	Automatic brightness / contrast
Brightness adjustment	Objective lens adjustment	Auto focus
Contrast adjustment	Photo Preview	Automatic astigmatism elimination
Magnification adjustment	Active ruler	Automatic filament adjustment
Selected area scanning mode	4 Scanning speed setting	Management of parameters
Point scanning mode	Objective lens inversion	Image snapshot, image freezing
Surface scanning	Condenser reversal	One Key Quick View
Horizontal line scanning	Electric rotation adjustment	





## A63.7069 Multi-angle



SEM	A63.7069	A63.7080	A63.7081
Resolution	3nm@30KV(SE) 6nm@30KV(BSE)	1.5nm@30KV(SE) 3nm@30KV(BSE)	1.0nm@30KV(SE) 3.0nm@1KV(SE) 2.5nm@30KV(BSE)
Magnification	8x~300000x Negative True Magnification	8x~800000x Negative True Magnification	6x~1000000x Negative True Magnification
Electron Gun	Pre-Centered Tungsten Filament Cartridge	Schottky Field Emission Gun	Schottky Field Emission Gun
Voltage	Accelerating Voltage 0~30KV, Continuous Adjustable, Adjust Step 100V@0-10Kv, 1KV@10-30KV		
Quick View	One Key Quick View Image Function	N/A	N/A
Lens System	Three-levels Electromagnetic Tapered Lens	Multi-levels Electromagnetic Tapered Lens	
Aperture	3 Molybdenum Objective Apertures, Adjustable Outside Of Vacuum System, No Need Disassemble Objective To Change Aperture		
Vacuum System	1 Turbo Molecular Pump 1 Mechanical Pump Sample Room Vacuum>2.6E-3Pa Electron Gun Room Vacuum>2.6E-3Pa Fully Auto Vacuum Control Vacuum Interlock Function  <b>Optional Model: A63.7069-LV</b> 1 Turbo Molecular Pump 2 Mechanical Pumps Sample Room Vacuum>2.6E-3Pa Electron Gun Room Vacuum>2.6E-3Pa Fully Auto Vacuum Control Vacuum Interlock Function <b>Low Vacuum Range 10~270Pa</b> For Quick Switch in 90 Seconds For BSE(LV)	1 Ion Pump Set 1 Turbo Molecular Pump 1 Mechanical Pump Sample Room Vacuum>6E-4Pa Electron Gun Room Vacuum>2E-7 Pa Fully Auto Vacuum Control Vacuum Interlock Function	1 Sputter Ion Pump 1 Getter Ion Compound Pump 1 Turbo Molecular Pump 1 Mechanical Pump Sample Room Vacuum>6E-4Pa Electron Gun Room Vacuum>2E-7 Pa Fully Auto Vacuum Control Vacuum Interlock Function
Detector	<b>SE:</b> High Vacuum Secondary Electron Detector (With Detector Protection)	<b>SE:</b> High Vacuum Secondary Electron Detector (With Detector Protection)	<b>SE:</b> High Vacuum Secondary Electron Detector (With Detector Protection)
	<b>BSE:</b> Semiconductor 4 Segmentation Back Scattering Detector	Optional	Optional
	<b>Optional Model: A63.7069-LV BSE(LV):</b> Semiconductor 4 Segmentation Back Scattering Detector		
	<b>CCD:</b> Infrared CCD Camera	<b>CCD:</b> Infrared CCD Camera	<b>CCD:</b> Infrared CCD Camera
Extend Port	2 Extend Ports On Sample Room For EDS, BSD, WDS etc.	4 Extend Ports On Sample Room For BSE, EDS, BSD, WDS etc.	4 Extend Ports On Sample Room For BSE, EDS, BSD, WDS etc.

Specimen Stage	5 Axes Stage, 4 <b>Auto</b> +1 <b>Manual</b> Control Travel Range: X=70mm, Y=50mm, Z=45mm, R=360°, T=-5°~+90°(Manual) Touch Alert & Stop Function	5 Axes <b>Auto Middle</b> Stage Travel Range: X=80mm, Y=50mm, Z=30mm, R=360°, T=-5°~+70° Touch Alert & Stop Function  Optional Model: <b>A63.7080-M</b> 5 Axes <b>Manual</b> Stage <b>A63.7080-L</b> 5 Axes <b>Auto Large</b> Stage	5 Axes <b>Auto Large</b> Stage Travel Range: X=150mm, Y=150mm, Z=60mm, R=360°, T=-5°~+70° Touch Alert & Stop Function
Max Specimen	Dia.175mm, Height 35mm	Dia.175mm, Height 20mm	Dia.340mm, Height 50mm
Image System	Real Still Image Max Resolution 4096x4096 Pixels, Image File Format: BMP(Default), GIF, JPG, PNG, TIF	Real Still Image Max Resolution 16384x16384 Pixels, Image File Format: TIF(Default), BMP, GIF, JPG, PNG Video: Auto Record Digital .AVI Video	Real Still Image Max Resolution 16384x16384 Pixels, Image File Format: TIF(Default), BMP, GIF, JPG, PNG Video: Auto Record Digital .AVI Video
Computer & Software	PC Work Station Win 10 System, With Professional Image Analysis Software To Fully Control Whole SEM Microscope Operation, Computer Specification No Less Than Inter I5 3.2GHz, 4G Memory, 24" IPS LCD Monitor, 500G Hard Disk, Mouse, Keyboard		
Photo Display	The Image Level Is Rich And Meticulous, Showing Real Time Magnification, Ruler, Voltage, Gray Curve		
Dimension & Weight	Microscope Body 800x800x1850mm Working Table 1340x850x740mm Total Weight 400Kg	Microscope Body 800x800x1480mm Working Table 1340x850x740mm Total Weight 450Kg	Microscope Body 1000x1000x1730mm Working Table 1330x850x740mm Total Weight 550Kg
<b>Optional Accessories</b>			
Optional Accessories	<b>A50.7002</b> EDS Energy Dispersive X-Ray Spectrometer <b>A50.7011</b> Ion Sputtering Coater	<b>A50.7001</b> BSE Back Scattering Electron Detector <b>A50.7002</b> EDS Energy Dispersive X-Ray Spectrometer <b>A50.7011</b> Ion Sputtering Coater <b>A50.7030</b> Motorize Control Panel	<b>A50.7001</b> BSE Back Scattering Electron Detector <b>A50.7002</b> EDS Energy Dispersive X-Ray Spectrometer <b>A50.7011</b> Ion Sputtering Coater <b>A50.7030</b> Motorize Control Panel

## Product Accessories



**A50.7001**  
BSE Detector



**A50.7002**  
EDS (X Ray Detector)



**A50.7003**  
EBSD (Electron  
Beam Backscattered  
Diffraction)



**A50.7013**  
Critical Point Dryer



**A50.7010**  
Coating Machine



**A50.7011**  
Ion Sputtering Coater



**A50.7012**  
Argon Ion  
Sputtering Coater

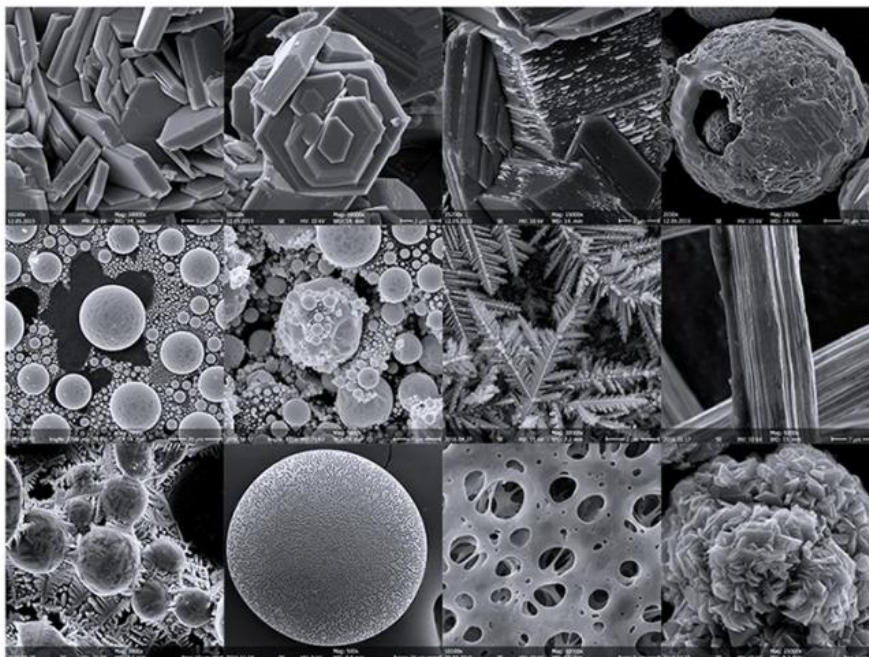


**A50.7014**  
Electron Beam  
Lithography

<b>A50.7001</b>	BSE Detector	Semiconductor Four Segment Back Scattering Detector; Available In Ingredients A+B, Morphology Info A-B; Available Sample Observe Without Sputtering Gold; Available In Observe Impurity And Distribution From Grayscale Map Directly.
<b>A50.7002</b>	EDS (X Ray Detector)	Silicon Nitride (Si3N4) Window To Optimize Low Energy X-ray Transmission For Light Element Analysis; Excellent Resolution And Their Advanced Low-noise Electronics Provide Outstanding Throughput Performance; The Small Footprint Offers Flexibility To Ensure Ideal Geometry And Aata Collection Conditions; The Detectors Contain A 30mm2 Chip.

A50.7003	EBSD (Electron Beam Backscattered Diffraction)	<p>user could analysis crystal orientation, crystal phase and micro texture of materials and related materials performance,etc.  automatic optimization of EBSD camera settings  during the data collection, do interactive real-time analysis to obtain maximum information  all the data were branded with time tag, which can be viewed at any time  high resolution 1392 x 1040 x 12  Scanning and index speed: 198 points / sec, with Ni as the standard, under the condition of 2~5nA, it can ensure the index rate ≥99%;  works well under the condition of low beam current and low voltage of 5kV at 100pA orientation measuring accuracy: Better than 0.1 degrees  Using triplex index system: no need rely on single band definition , easy indexing of poor pattern quality  dedicated database: EBSD special database obtained by electron diffraction: &gt;400 phase structure  Index ability: it can automatically index all crystal materials of 7 crystal systems.  The advanced options include calculating elastic stiffness (Elastic Stiffness), Taylor (Taylor) factor, Schmidt (Schmid) factor and so on.</p>
A50.7010	Coating Machine	<p>Glass Protecting Shell: ∅ 250mm; 340mm High;  Glass Processing Chamber:  ∅ 88mm; 140mm High, ∅ 88mm; 57mm High;  Specimen Stage Size: ∅ 40mm (max);  Vacuum System:molecula Pump And Mechanical Pump;  Vacuum Detection: Pirani Gage;  Vacuum:better Than 2 X 10<sup>-3</sup> Pa;  Vacuum Protection:20 Pa With Microscale Inflation Valve;  Specimen Movement: Plane Rotation,tilt Precession.</p>
A50.7011	Ion Sputtering Coater	<p>Glass Processing Chamber: ∅ 100mm; 130mm High;  Specimen Stage Size: ∅ 40mm( Hold 6 Specimen Cups) ;  Golden Target Size: ∅ 58mm*0.12mm(thickness);  Vacuum Detection: Pirani Gage;  Vacuum Protection:20 Pa With Microscale Inflation Valve;  Medium Gas:argon Or Air With Argon Gas Special Air Inlet And Gas Regulating In Microscale.</p>
A50.7012	Argon Ion Sputtering Coater	<p>The Sample Was Plated With Carbon And Gold Under High Vacuum;  Rotatable Sample Table, Uniform Coating, Particle Size About 3-5nm;  No Selection Of Target Material, No Damage To Samples;  The Functions Of Ion Cleaning And Ion Thinning Can Be Realized.</p>
A50.7013	Critical Point Dryer	<p>Inner Diameter: 82mm, Inner Length: 82mm;  Pressure Range:0-2000psi;  Temperature Range:0°-50° C (32°-122° F)</p>
A50.7014	Electron Beam Lithography	<p>Based On Scanning Electron Microscope, A Novel Nano-exposure System Was Developed;  The Modificaton Has Kept All The Sem Functions For Making Nanoscale Line Width Image;  The Modified ebl System Widly Applied Into Microelectronic Devices, Optoelectronic Devices, Quantun Devices, Microelectronics System R&amp;d.</p>

## Real Effect



### A63.7069 Standard Consumables Outfit

1	Tungsten Filament	Pre-centered, Imported	1 Box (5 pcs)
2	Sample Cup	Dia.13mm	5 Pcs
3	Sample Cup	Dia.32mm	5 Pcs
4	Carbon Double-sided Conductive Tape	6mm	1 Package
5	Vacuum Grease		10 Pcs
6	Hairless Cloth		1 Tube
7	Polishing Paste		1 Pc
8	Sample Box		2 Bags
9	Cotton Swab		1 Pc
10	Oil Mist Filter		1 Pc

### A63.7069 Standard Tools & Parts Outfit

1	Inner Hexagon Spanner	1.5mm~10mm	1 Set
2	Tweezers	Length 100-120mm	1 Pc
3	Slotted Screwdriver	2*50mm, 2*125mm	2 Pcs
4	Cross Screwdriver	2*125mm	1 Pc
5	Diaphragm Remover		1 Pc
6	Cleaning Rod		1 Pc
7	Filament Adjustment Tool		1 Pc
8	Filament Adjusting Gasket		3 Pc
9	Tube Extractor		1 Pc

## Working Condition, Requirement For Installation

### 1. Applications:

SEM is mainly applied to the specimen surface appearance analysis. It is equipped with energy spectrum which is used for composition analysis and equipped with a small ion sputtering apparatus to help with sample surface treatment.

### 2. Power Supply Requirements:

2.1 Voltage: AC 220V  $\pm$  10%, 50Hz  $\pm$  1 Hz, standard sine wave.

2.2 It is not recommended to share the power supply line with the instrument for equipment with high power and large power consumption change.

2.3 Three power sockets needed for:

1. Scanning electron microscope instrument body, computer: AC 220V, 50Hz, 16A
2. Mechanical pump and air compressor: AC 220V, 50Hz, 16A

### 3. Environmental Requirements For Installation Site:

3.1 It is recommended to keep the temperature between 16~30 C

3.2 The relative humidity shall be less than 60%

3.3 Recommend configuration: air conditioner, dehumidifier and other equipment that can ensure the temperature and humidity of the laboratory.

3.4 Noise: < 68 DB

3.5 The durability of the instrument operation: continuously working

### 4. A63.7069 Instrument Dimension & Weight

Microscope Body 800x800x1850mm

Working Table 1340x850x740mm

Total Weight 400Kg

The floor bearing capacity should  $\geq$  250kg/m<sup>3</sup>, and it is recommended to place it on the first floor

### 5. A63.7069 Packaging Dimension & Weight

1 Set in 3 Wooden Boxes:

110\*110\*158(cm) \*1

127\*115\*136(cm) \*1

160\*80\*111 (cm) \*1

Total Volume 5.3189CBM, Total G.W. 872 kg

## After-sale Service

--Standard 1 Year Warranty Included

--Extend Warranty 1 Year Cost 12% of Sales Contrast Amount

--On-Site Installation Cost USD6000.0 For 5+2 Days

--On-Site Maintenance Cost USD4500.0 For 3+2 Days

--Free Training for Visiting Customer in Beijing Included (Round Trip Ticket & Lodging Fee Not Included)

--Consumables Items & Accessories Available For All Life Time of Machine



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